

WORKSHOP on Maskless Direct-Write Technologies for the Advanced Micro & Nano-Fabrication

Date: 18 Dec 2023
09:00 AM to 01:30

PM

CeNSE, IISc-
Bengaluru Seminar

Hall

[Register Here](#)



Know more about Hei-
delberg Instruments
Mikrotechnik



Labindia Instruments Pvt. Ltd
201, Nand Chambers, L B S Marg,
Near Vandana Cinema,
Thane - 400 602.

Program Agenda

09:00 AM to 09:30 AM	Registration
09:30 AM to 10:00 AM	Inauguration and Introduction by Prof. Shankar Kumar Selvaraja, CeNSE, IISc-Bangalore
10:00 AM to 10:45 AM	Heidelberg Instruments – Company and Product Overview – Focus on Maskless Aligner and Maskless Stepper by Dr. Sven Preuss Heidelberg Instruments
10:45 AM to 11:15 AM	Empowering microfabrication research with the DWL66+ and unveiling the potential of grayscale lithography by Dominique Collé, Heidelberg Instruments
11:15AM-11:30AM Coffee/Tea Break	
11:30 AM to 12:00 PM	Laser lithography 2D and 3D corrections by Dmitri Titko, GenlSys
12:00 PM to 12:30 PM	NanoFrazor Lithography for advanced 2D&3D nanodevices by Vasileios Theofylaktopoulos, Heidelberg Instruments
12:30 PM to 01:00 PM	Talk about Industry Tools/Applications (Focus on MLA 300, ULTRA, VPG) Mask Making by Wolfgang, Heidelberg Instruments
01:00 PM to 01:30 PM	The MPO 100: 3D Lithography and 3D Micro-printing via Two-Photon Polymerization by Dr. Daniel-Alexander Braun, Heidelberg Instruments
Lunch and Networking	

[Contact US](#)

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